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STATEMENT BY APPLICANT

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Sheet 1 of 1

Compl t if Known					
Application Number	09/843,023				
Filing Date	April 26, 2001				
First Named Inventor	Becky Losee				
Group Art Unit	Unassigned				
Examiner Name	Unassigned				
Attorney Docket Number	40013.002				

U.S. PATENT DOCUMENTS						
Examiner Initials	Cite No. ¹	U.S. Patent Number	Document Kind Code ² (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
pun	i	5,843,226		Zhao et al.	12-01-1998	Figs, 1-3
KUNU	2	6,121,154		Haselden et al.	09-19-2000	F 10 4
WIN.	3	6,191,043		McReynolds	02-20-2001	FUB. SASB & 7
WIN.	4	6,069,086		Nallan et al.	05-30-2000	Colon, 1. line 65-cal. 3, l. 36
XUN.	5	6,069,091		Chang et al.		4-1.cast
(800)	4	6,180,533		Jain et al.	01-30-2001	FOS.6A-67
We 110	7	6,175,144		Gardner et al.	01-16-2001	ولمحتاع
XU17	8	6,103,635		Chau et al.		Fight 9A-9F
OR NO >	9	6,188,564		Hao	02-13-2001	colum 3. Dine 16-0.4. D.8
CREDIT	10	5,935,874		Kennard	08-10-1999	Fig.3
8						
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	FOREIGN PATENT DOCUMENTS							
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Examiner Initials*	Cite No. ¹	Office ³	Number ⁴	Kind Code ⁵ (if known)	Applicant of Cited Document	Cited Document MM-DD-YYYY	Passages or Relevant Figures Appear	T ⁶
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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bstitute for form 1449B/PTO NFORMATION DISCLOSURE STATEMENT BY APPLICANT

Compl te if Kn wn 09/843,023 **Application Number** April 26, 2001 Filing Date **Becky Losee** First Named Inventor Unassigned **Group Art Unit** Unassigned **Examiner Name** 40013.002 Attorney Docket Number

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		OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
flin		A. BURTSEV et al. "An anisotropic U-shaped SF, based plasma silicon trench etching investigation" Microelectronic Engineering 40 (1998) 85-97.	
teal		Y.X. Li and R.F. Wolffenbuttel "Development of a deep silicon plasma etching process for sensor application" SPIE Vol. 2639; pages 244-252.	1
lear		A.A. Ayon et al. "Deep Reactive Ion Etching of Silicon" Materials Research Society Symp. Proc. Vol. 546; pages 51-61.	1
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